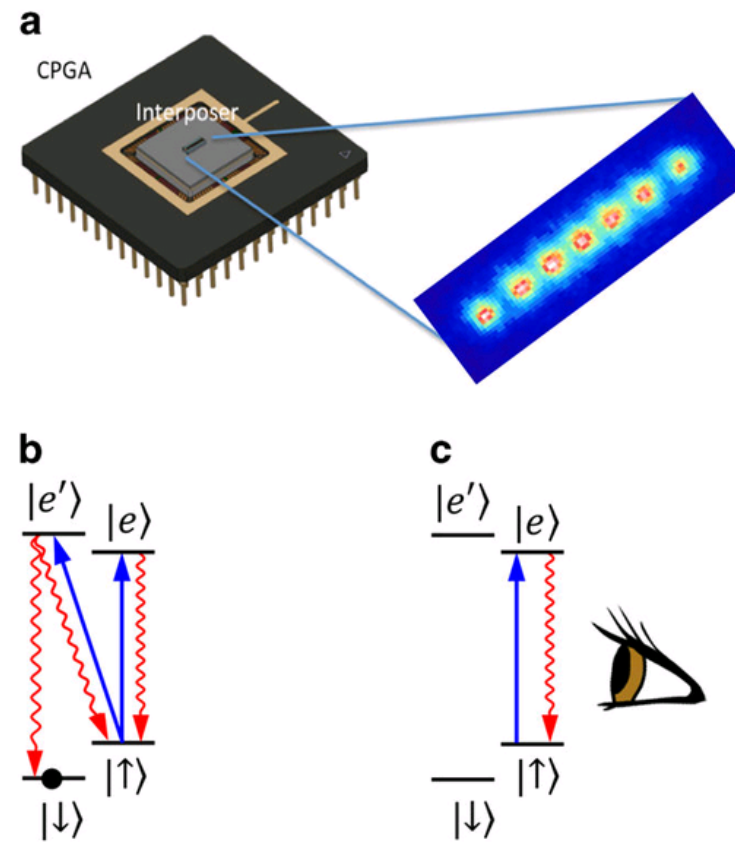


Ion Trap Quantum Device



(a) Schematic of silicon chip-trap mounted on a ceramic pin grid array carrier with raised interposer, confining atomic ions that hover $\sim 75 \mu\text{m}$ above the surface. The inset is an image of 7 atomic ytterbium ($^{171}\text{Yb}^+$) ions arranged in a linear crystal and laser-cooled to be nearly at rest. The few-micrometre separation between ions is determined by a balance between the external confinement force and Coulomb repulsion. (b,c) Reduced energy level diagram of a single $^{171}\text{Yb}^+$ atomic ion, showing the atomic hyperfine levels $|\uparrow\rangle$ and $|\downarrow\rangle$ that represent a qubit. The electronic excited states $|e\rangle$ and $|e'\rangle$ are separated from the ground states by an energy corresponding to an optical wavelength of 369.53 nm, and applied laser radiation (blue arrows) drives these transitions for (b) initialisation to state $|\downarrow\rangle$, and (c) fluorescence detection of the qubit state ($|\uparrow\rangle$, fluorescence, $|\downarrow\rangle$, no fluorescence).